LAYER by TAFNEX™

Stool type Bench type



"LAYER by TAFNEX™"

MITSUI CHEMICALS, INC. × JUNICHIRO YOKOTA STUDIO

The material used in exhibition is TAFNEX[™] end chips generated in its production process. Those chips are usually treated as industrial wastes and discarded, but once integrated into a singular material form TAFNEX[™].

The benches and stools on display are designed to embody this characteristic. Composed of two overlapping upper and lower sections, each individual part has a shape that cannot stand on its own. Only once combined do these two imperfect parts form a complete product.

Design: JUICHIRO YOKOTA STUDIO

Production: ARRK

TAFNEX™ Random sheet Production : SUNCORONA ODA



